



**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT PTO-1449**

Docket No. 52433/830	Application No. 10/561,133
Applicant(s) Natsuko SUGIURA, et al.	Examiner Deborah YEE
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U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE mm/dd/yyyy	NAME	CLASS	SUBCLASS	FILING DATE

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE mm/dd/yyyy	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						Yes	No
	2001-064750	03/13/2001	JP			Abstract	
	98/32889	07/30/1998	PCT			Abstract	
	1246161	03/01/2000	CN			corresponding to WO 98/32889	

OTHER DOCUMENTS

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
	Chinese Patent issued March 12, 2008 in corresponding Chinese Patent Application No.: CN 200480017463.3

EXAMINER	DATE CONSIDERED
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	